PTO/SB/30 (08-00) Approved for use through 10/31/2002. OMB 0651-0031

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## **FOR CONTINUED EXAMINATION (RCE) TRANSMITTAL**

Subsection (b) of 35 U.S.C. § 132, effective on May 29, 2000, provides for continued examination of an utility or plant application filed on or after June 8, 1995.

See The American Inventors Protection Act of 1999 (AIPA).

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Application Number	10/091,461			
Filing Date	March 7, 2002			
First Named Inventor	MASATAKA ITO			
Group Art Unit	2812			
Examiner Name	Stanetta D. Isaac			
Attorney Docket Number	00862.022541			

NOTE: 37 C.F.R. § 1.114 is effective on May 29, 2000. If the above-identified application was filed prior to May 29, 2000, applicant may wish to consider filing a continued prosecution application (CPA) under 37 C.F.R. § 1.53(d) (PTO/SB/29) instead of a RCE to be eligible for the patent term adjustment provisions of the AIPA. See Changes to Application Examination and Provisional Application Practice, Final Rule, 65 Fed. Reg. 50092 (Aug. 16, 2000); Interim Rule, 65 Fed. Reg. 14865 (Mar. 20, 2000), 1233 Off. Gaz. Pat. Office 47 (Apr. 11, 2000), which established RCE practice.							
1. Submission required under 37 C.F.R. § 1.114							
a. Previously submitted							
i. Consider the amendment(s)/reply under 37 C.F.R. § 1.116 previously filed on							
b. 🗵 Enclosed							
i. Amendment/Reply ii. Affidavit(s)/Declaration(s) iii. Information Disclosure Statement (IDS) iv. X Other Preliminary Amendment							
2. Miscellaneous							
a. Suspension of action on the above-identified application is requested under 37 C.F.R. § 1.103(c) for a period of months. (Period of suspension shall not exceed 3 months; Fee under 37 C.F.R. § 1.17(i) required)							
b. Other							
3. Fees The RCE fee under 37 C.F.R. § 1.17(e) is required by 37 C.F.R. § 1.114 when the RCE is filed.							
a. The Director is hereby authorized to charge any deficiencies in the following fees, or credit any overpayments, to Deposit Account No. 06-1205							
i. X RCE fee required under 37 C.F.R. § 1.17(e) 07/15/2004 HALI11 00000146 10091461 ii. X Extension of time fee (37 C.F.R. §§ 1.136 and 1.17) iii. Other 770.00 0P							
b. Check in the amount of \$ 770.00 is enclosed							
c. Payment by credit card (Form PTO-2038 enclosed)							
SIGNATURE OF APPLICANT, ATTORNEY, OR AGENT REQUIRED							
Name (Print/Type) Damond E. Vadnais / Registration No. (Attorney/Agent) 52,310							
Signature Date July 13, 2004							
CERTIFICATE OF MAILING OR TRANSMISSION							
I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Mail Stop RCE, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, or facsimile transmitted to the U.S. Patent and Trademark Office on:							
Name (Print/Type)							
Signature  Date  Date  Burden Hour Statement: This form is estimated to take 0.2 hours to complete. Time will year depending upon the needs of the individual case. Any							

comments on the amount of time you are required to complete this form should be sent to the Chief Information Officer, Director of the U.S.P.T.O., P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND Fees and Completed Forms to the following address: Mail Stop RCE, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

OTPE COS

In re Application of:

**MASATAKA ITO** 

Application No.: 10/091,461

Filed: March 7, 2002

For: SOI SUBSTRATE, ANNEALING METHOD THEREFOR, SEMICONDUCTOR DEVICE

HAVING THE SOI SUBSTRATE, AND

METHOD OF MANUFACTURING THE SAME

Docket No. 00862.022541

Examiner: Stanetta D. Isaac

Group Art Unit: 2812

Date: July 13, 2004

Mail Stop RCE Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Transmitted herewith is a Preliminary Amendment in the above-identified application.

X No additional fee is required.

The fee has been calculated as shown below

CLAIMS AS AMENDED						
	(2) CLAIMS REMAINING AFTER AMENDMENT		(4) HIGHEST NO. PREVIOUSLY PAID FOR	(5) PRESENT EXTRA	RATE	ADDITIONAL FEE
TOTAL CLAIMS	18	MINUS	20	= 0	x \$9 \$18	\$ 0.00
INDEP. CLAIMS	2	MINUS	3	= 0	x \$43 \$86	\$ 0.00
Fee for Multiple Dependent claims \$145°/\$290						\$ 0.00
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT						\$ 0.00

	Verified Statement claiming small entity status is enclosed, if not filed previously.				
	A check in the amount of \$ is enclosed.				
	Charge \$ to Deposit Account No. 06-1205. A duplicate copy of this sheet is enclosed				
X	Any prior general authorization to charge an issue fee under 37 C.F.R. 1.18 to Deposit Account No. 06 1205 is hereby revoked. The Commissioner is hereby authorized to charge any additional fees under 37 C.F.R. 1.16 and 1.17 which may be required during the entire pendency of this application, or to credit any overpayment, to Deposit Account No. 06-1205. A duplicate copy of this paper is enclosed.				
	A check in the amount of \$ to cover the fee for a month extension is enclosed.				
X	A check in the amount of \$ 770.00 to cover the Request for Continued Examination (RCE) fee is enclosed.				
X	Applicants' undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.				
	Respectfully submitted,				
	Attorney for Applicants Damond E. Vadnais Registration No. 52,310				

FITZPATRICK, CELLA, HARPER & SCINTO 30 Rockefeller Plaza
New York, New York 10112-3800
Facsimile: (212) 218-2200
DEV/vc

Form #120

DC\_MAIN 171290v1



## **PATENT APPLICATION**

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re .	Application of:	)	
	••	:	Examiner: Stanetta D. Isaac
MAS	ATAKA ITO	)	
		:	Group Art Unit: 2812
Appli	cation No.: 10/091,461	)	
		:	
Filed:	March 7, 2002	)	
		:	
For:	SOI SUBSTRATE, ANNEALING	)	
	METHOD THEREFOR,	:	
	SEMICONDUCTOR DEVICE HAVING	)	
	THE SOI SUBSTRATE, AND METHOD	:	
	OF MANUFACTURING THE SAME	)	July 13, 2004

Mail Stop RCE Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

## **PRELIMINARY AMENDMENT**

Sir:

Preliminary to examination, please amend the above-identified application, as

follows: